IN THE UNITED STATES PATENT AND TRADEMARK OFFICE /2/3/3
PATENT APPLICATION OF Confirmation No.: 3971

Inste PATENT APPLICATION OF

OI et al.

Group Art Unit: 2815

Application No. 09/421,322

Examiner: ECKERT II, GEORGE

Filed: October 18, 1999

Title: DIELECTRICALLY SEPARATED WAFER AND METHOD

OF MANUFACTURING THE SAME

November 24, 2003

AMENDMENT WITH REQUEST FOR CONTINUED EXAMINATION

Hon. Commissioner of Patents P.O. BOX 1450 Alexandria, VA 22313

Sir:

In response to the Office Action dated July 24, 2003, please amend the aboveidentified application as follows: